



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Re Application of)
)
Hiroki Adachi)
)
Serial No.: 09/437,649)
)
Filed: November 10, 1999)
)
For: Exposure Device, Exposure Method)
And Method Of Manufacturing)
Semiconductor Device)
)
Art Unit: 2814)
)
Examiner: S. Rao)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to:
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May 19, 2004
(Date of Deposit)

Shannon Wallace

Name of applicant, assignee, or Registered Rep.

Shannon Wallace 5/19/04
Signature Date

AMENDMENT D (AFTER FINAL)

Sir:

In response to the Final Rejection dated December 31, 2003 and Advisory Action dated May 11, 2004, a two month extension of time and RCE being submitted herewith, please amend the above-identified application as follows: